

# Raith Online User Meeting Europe



Date and Time: October, 7<sup>th</sup> 2021; 09:00 – 12:00, CEST

Venue: GoTo Webinar  
Please register here:

<https://attendee.gotowebinar.com/register/5055104082331516686>

09:00 – 09:05	<b>Introduction,</b> Andreas Remscheid, Raith GmbH
09:05 – 09:20	<b>Raith Company Update</b> Dirk Brüggemann, Raith GmbH
09:20 – 09:50	<b>VELION – A versatile FIB-SEM instrument to overcome nanofabrication constraints</b> Torsten Richter, Raith GmbH
09:50 – 10:20	<b>Laser Lithography</b> Otto Carel, Raith B.V.
10:30 – 11:15	<b>The new EBP Plus: E-Beam Lithography with a Plus in Throughput and Precision</b> Frank Nouvertne, Raith GmbH
11:15 – 12:00	<b>Q&amp;A about the day</b> all